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P2001,0678

CERTIFICATION OF MAILING OR FAX TRANSMISSION

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By: Honglong Chen Date: July 19, 2005IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/813,530 Confirmation No. 5329  
Applicant : Volker Härle et al.  
Filed : March 29, 2004  
TC/A.U. : 2818  
Examiner : Chuong A. Luu  
Title : Method for Fabricating a Semiconductor  
Component Based on a Nitride Compound  
Semiconductor

Docket No. : P2001,0678  
Customer No. : 24131

Hon. Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE**

S i r :

In response to the Office action dated April 19, 2005, please  
consider the following:

Remarks/Arguments begin on page 2 of this paper.